


ITW

AMENDMENT TRANSMITTAL LETTER (Large Entity)					Docket No. OKI.548	
Applicant(s): Akira Takahashi						
Application No. 10/619,592	Filing Date July 16, 2003	Examiner D. Deo	Customer No. 20987	Group Art Unit 1765	Confirmation No. 7452	
Invention: METHOD OF FABRICATING SEMICONDUCTOR DEVICE						
COMMISSIONER FOR PATENTS:						
Transmitted herewith is an amendment in the above-identified application.						
The fee has been calculated and is transmitted as shown below.						
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	22 -	20 =	2	x \$50.00	\$100.00	
INDEP. CLAIMS	3 -	3 =	0	x \$200.00	\$0.00	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$100.00	
<input type="checkbox"/> No additional fee is required for amendment.						
<input checked="" type="checkbox"/> Please charge Deposit Account No. 50-0238 in the amount of \$100.00						
<input type="checkbox"/> A check in the amount of to cover the filing fee is enclosed.						
<input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0238						
<input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16.						
<input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17.						
<input type="checkbox"/> Payment by credit card. Form PTO-2038.						
WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.						
<div style="display: flex; justify-content: space-between;"><div style="width: 45%;"> _____ <i>Signature</i></div><div style="width: 50%; text-align: right;">Dated: August 23, 2005</div></div>						
<div style="display: flex; justify-content: space-between;"><div style="width: 45%; border: 1px solid black; padding: 5px;">ANDREW J. TELESZ, JR. REG. NO. 33,581 VOLENTINE FRANCO & WHITT, P.L.L.C. 11951 FREEDOM DRIVE, SUITE 1260 RESTON, VA 20190 TEL. NO. (571) 283-0720</div><div style="width: 50%; border: 1px solid black; padding: 5px;"><div>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on</div><div>_____ (Date)</div><div>_____ <i>Signature of Person Mailing Correspondence</i></div><div>_____ <i>Typed or Printed Name of Person Mailing Correspondence</i></div></div></div>						
CC:						



Serial No. 10/619,592
OKI.548
Amendment dated August 23, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Akira Takahashi

Group Art Unit: 1765

Serial No.: 10/619,592

Examiner: D. Deo

Filed: July 16, 2003

Confirm: 7452

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE

AMENDMENT

U.S. Patent and Trademark Office
Customer Window, **Mail Stop Amendment**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Date: August 23, 2005

Sir:

In response to the Office Action dated May 25, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

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Remarks/Arguments begin on page 11 of this paper.